

01/16/02

**PATENT NUMBER and
ISSUE DATE**

U.S. UTILITY Patent Application

APPL NUM 10050644	FILING DATE 01/16/2002	CLASS 335	SUBCLASS 240	GAU 2832	EXAMINER Altman DALETZ
**APPLICANTS: Li Min; Liao Simon; Sano Masashi; Noguchi Kiyoshi; Ju Kochan; Horng Cheng; H3 142					
**CONTINUING DATA VERIFIED: None Ato					
** FOREIGN APPLICATIONS VERIFIED: None Ato					
PG-PUB		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials				ATTORNEY DOCKET NO HT01-022	
TITLE : FeTa nano-oxide layer as a capping layer for enhancement of giant magnetoresistance in bottom spin valve structures					
U.S. DEPT. OF COMM /PAT. & TM-PTO-436L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED		
			Total Claims	Print Claim for O.G.	
ISSUE FEE		Primary Examiner	DRAWING		
Amount Due	Date Paid		Sheet Drawg.	Figs. Drawg.	Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner		
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